Form PTO-1449 (Modified)

LIST OF PATENTS AND POR FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Atty Docket No.	Serial No.
F0039/AMDSP388US	09/515,348
Applicant:	
Christopher A. Spence,	et al
Filing Date	Group
February 29, 2000	1752-2621

U.S. PATENT DOCUMENTS

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OTHER ART

Examiner Initial	Author, Title, Date, Pertinent Pages, etc.							
4	Evaluation of Proximity Effects Using Three-Dimensional Optical Lithography Simulation, Chris A. Mack, SPIE Vol. 2726 Optical Microlithography IX (1996)							
\$/	Comparison of Binary Mask Defect Printability Analysis Using Virtual Stepper System and Aerial Image Microscope System, Khoi A. Phan, et al., Proc. SPIE Vol. 3873, p. 681-692, 19 th Annual Symposium on Photomask Technology, Frank E. Abboud; Brian B Grenon;							
	Eds. (12/99)	<u>. </u>						
	0.7	<u>`</u>						
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Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered, of this form with next communication to applicant.

Information Disclosure Statement PTO-1449 (Modified)

The identification of any reference is no intended to be, and should not be understood as being, an admission that such publication, in fact, constitutes "prior art" within the meaning of applicable law since, for example, a given reference may have a later effective date than first seems apparent or the reference may have an effective date which can be antedated. The "prior art" status of any reference is a matter to be resolved during prosecution.

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Examiner Initial	Document Number	Date	Name	Class	Sub- class	Filing Date if Appropriate
(B)	5,086,477	2/92	Yu, et al.	385	8	
1	6,072,897	6/00	Greenberg, et al.	382	144	
8	6,128,403	10/00	Ozaki	382	145	
(4)	6,175,953	1/01	Scepanovic, et al.	716	21	
8	6,334,209	12/01	Hashimoto, et al.	RECEIV	ΞD	
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EXAMINER Brian Werner DATE CONSIDERED 7/22/03			
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